# Computer Aided Design of Micro-Electro-Mechanical Systems From Energy Losses to Dick Tracy Watches

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1 / 65

## Collaborators

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- Sanjay Govindjee
- Tsuyoshi Koyama
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- Sunil Bhave
- Emmanuel Quévy
- ...

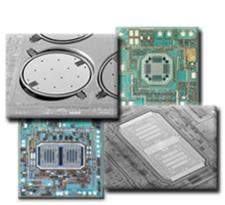
# The Computational Science Picture

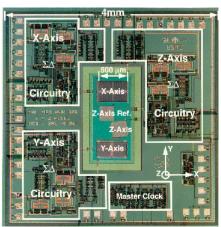
- Application modeling
  - Checkerboard filter
  - Disk resonator and radiation loss
  - Beam resonator and thermoelastic loss
  - Shear ring resonator
- Mathematical analysis
  - Physical modeling and finite element technology
  - Structured eigenproblems and reduced-order models
  - Parameter-dependent eigenproblems
- Software engineering
  - HiQLab
  - SUGAR
  - FEAPMEX / MATFEAP

# The Computational Science Picture

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## What are MEMS?

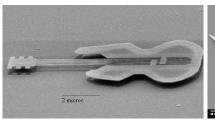


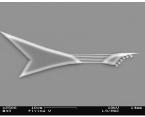


## **MEMS Basics**

- Micro-Electro-Mechanical Systems
  - Chemical, fluid, thermal, optical (MECFTOMS?)
- Applications:
  - Sensors (inertial, chemical, pressure)
  - Ink jet printers, biolab chips
  - Radio devices: cell phones, inventory tags, pico radio
- Use integrated circuit (IC) fabrication technology
- Tiny, but still classical physics

## Resonant RF MEMS

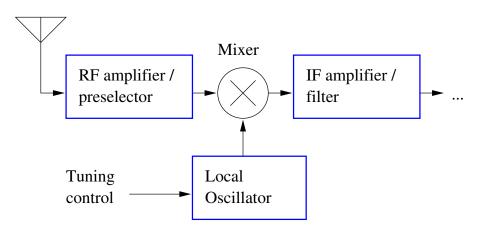




Microguitars from Cornell University (1997 and 2003)

- MHz-GHz mechanical resonators
- Favorite application: radio on chip
- Close second: really high-pitch guitars

## The Mechanical Cell Phone



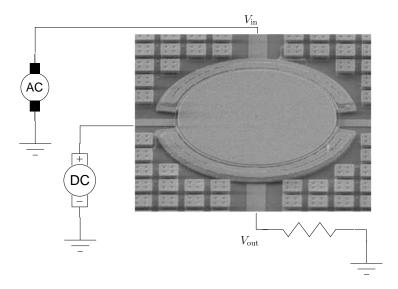
- Your cell phone has many moving parts!
- What if we replace them with integrated MEMS?

## **Ultimate Success**

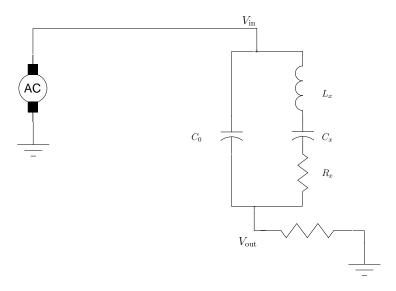
"Calling Dick Tracy!"



## **Disk Resonator**



## **Disk Resonator**



# The Designer's Dream

Want a reduced model for the electromechanical admittance

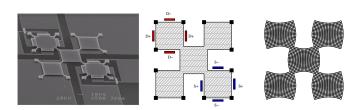
$$Y(\omega) = i\omega C + G + i\omega H(\omega)$$
  
 $H(\omega) = B^{T}(\tilde{K} - \omega^{2}M)^{-1}B$ 

Ideally, would like

- Simple models for behavioral simulation
- Parameterized for design optimization
- With reasonably fast and accurate set-up
- Including all relevant physics

Lots of linear algebra problems left!

## **Checkerboard Resonator**

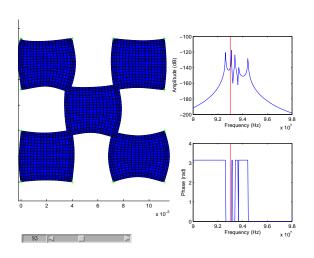


- Anchored at outside corners
- Excited at northwest corner
- Sensed at southeast corner
- Surfaces move only a few nanometers

## **Checkerboard Model Reduction**

- Finite element model: N = 2154
  - Expensive to solve for every  $H(\omega)$  evaluation!
- Build a reduced-order model to approximate behavior
  - Reduced system of 80 to 100 vectors
  - Evaluate  $H(\omega)$  in milliseconds instead of seconds
  - Without damping: standard Arnoldi projection
  - With damping: Second-Order ARnoldi (SOAR)

## **Checkerboard Simulation**



# Damping and Q

Designers want high quality of resonance (Q)

Dimensionless damping in a one-dof system

$$\frac{d^2u}{dt^2} + Q^{-1}\frac{du}{dt} + u = F(t)$$

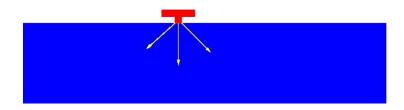
• For a resonant mode with frequency  $\omega \in \mathbb{C}$ :

$$Q := \frac{|\omega|}{2\operatorname{Im}(\omega)} = \frac{\operatorname{Stored\ energy}}{\operatorname{Energy\ loss\ per\ radian}}$$

To understand Q, we need damping models!

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# Damping Mechanisms



#### Possible loss mechanisms:

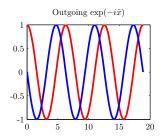
- Fluid damping
- Material losses
- Thermoelastic damping
- Anchor loss

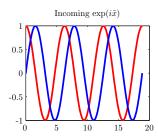
Model substrate as semi-infinite with a

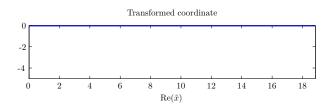
Perfectly Matched Layer (PML).

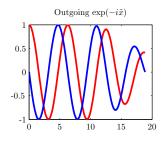
# Perfectly Matched Layers

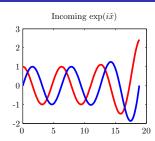
- Complex coordinate transformation
- Generates a "perfectly matched" absorbing layer
- Idea works with general linear wave equations
  - Electromagnetics (Berengér, 1994)
  - Quantum mechanics exterior complex scaling (Simon, 1979)
  - Elasticity in standard finite element framework (Basu and Chopra, 2003)

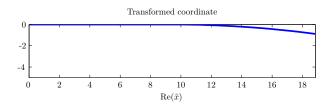


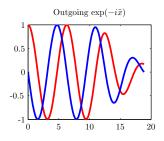


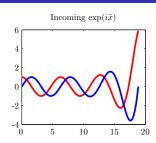


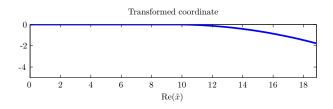


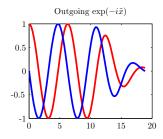


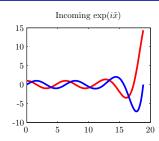


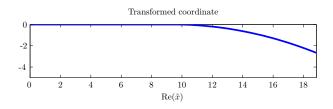


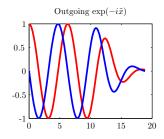


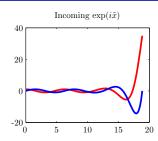


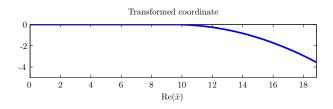


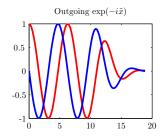


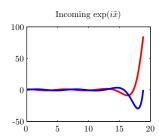


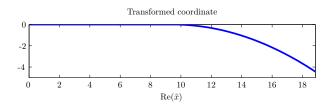




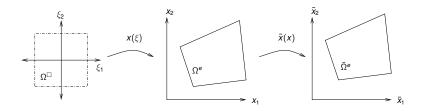








# Finite Element Implementation



Combine PML and isoparametric mappings

$$\mathbf{k}^{e} = \int_{\Omega^{\square}} \tilde{\mathbf{B}}^{T} \mathbf{D} \tilde{\mathbf{B}} \tilde{J} d\Omega^{\square}$$
$$\mathbf{m}^{e} = \int_{\Omega^{\square}} \rho \mathbf{N}^{T} \mathbf{N} \tilde{J} d\Omega^{\square}$$

• Matrices are complex symmetric

# Eigenvalues and Model Reduction

Want to know about the transfer function  $H(\omega)$ :

$$H(\omega) = B^{T}(K - \omega^{2}M)^{-1}B$$

#### Can either

- Locate poles of H (eigenvalues of (K, M))
- Plot H in a frequency range (Bode plot)

Usual tactic: subspace projection

- Build an Arnoldi basis V for a Krylov subspace  $\mathcal{K}_n$
- Compute with much smaller V\*KV and V\*MV

Can we do better?

# Variational Principles

- Variational form for complex symmetric eigenproblems:
  - Hermitian (Rayleigh quotient):

$$\rho(\mathbf{v}) = \frac{\mathbf{v}^* \mathbf{K} \mathbf{v}}{\mathbf{v}^* \mathbf{M} \mathbf{v}}$$

Complex symmetric (modified Rayleigh quotient):

$$\theta(v) = \frac{v^T K v}{v^T M v}$$

(Hochstenbach and Arbenz, 2004)

- First-order accurate eigenvectors Second-order accurate eigenvalues.
- Key: relation between left and right eigenvectors.

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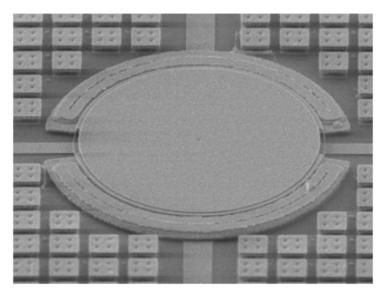
## **Accurate Model Reduction**

• Build new projection basis from *V*:

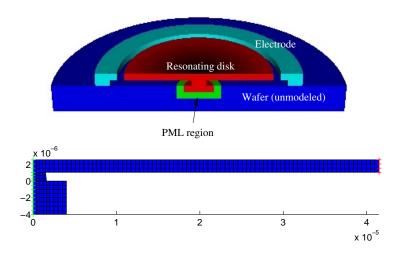
$$W = \operatorname{orth}[\operatorname{Re}(V), \operatorname{Im}(V)]$$

- span(W) contains both  $\mathcal{K}_n$  and  $\bar{\mathcal{K}}_n$   $\Longrightarrow$  double digits correct vs. projection with V
- W is a real-valued basis
   projected system is complex symmetric

## **Disk Resonator Simulations**

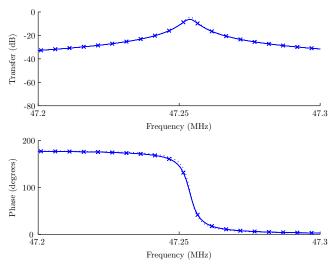


## Disk Resonator Mesh



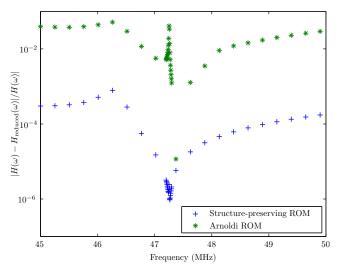
- Axisymmetric model with bicubic mesh
- About 10K nodal points in converged calculation

# Model Reduction Accuracy



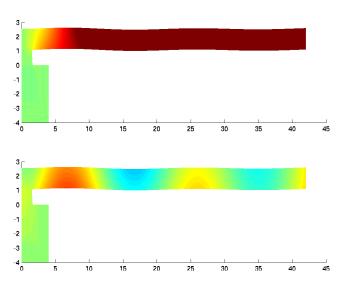
Results from ROM (solid and dotted lines) nearly indistinguishable from full model (crosses)

# Model Reduction Accuracy



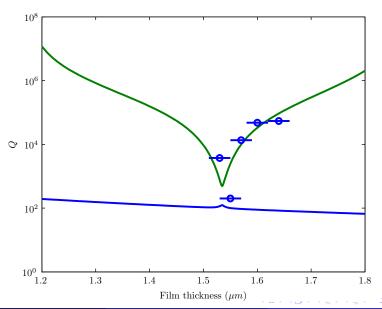
Preserve structure  $\implies$  get twice the correct digits

# Response of the Disk Resonator

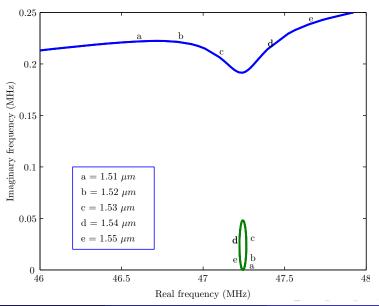


27 / 65

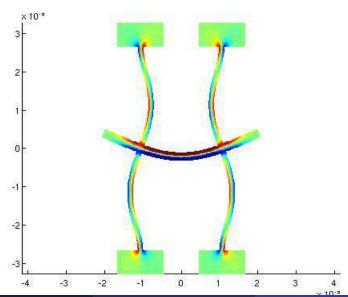
# Variation in Quality of Resonance



# Explanation of Q Variation



# Thermoelastic Damping (TED)



# Thermoelastic Damping (TED)

*u* is displacement and  $T = T_0 + \theta$  is temperature

$$\sigma = C\epsilon - \beta\theta \mathbf{1} 
\rho \ddot{u} = \nabla \cdot \sigma 
\rho c_{V} \dot{\theta} = \nabla \cdot (\kappa \nabla \theta) - \beta T_{0} \operatorname{tr}(\dot{\epsilon})$$

- Coupling between temperature and volumetric strain:
  - Compression and expansion ⇒ heating and cooling

  - Not often an important factor at the macro scale
  - Recognized source of damping in microresonators
- Zener: semi-analytical approximation for TED in beams
- We consider the fully coupled system

# Nondimensionalized Equations

#### Continuum equations:

$$\begin{aligned}
\sigma &= \hat{C}\epsilon - \xi\theta \mathbf{1} \\
\ddot{u} &= \nabla \cdot \sigma \\
\dot{\theta} &= \eta \nabla^2 \theta - \mathsf{tr}(\dot{\epsilon})
\end{aligned}$$

#### Discrete equations:

$$M_{uu}\ddot{u} + K_{uu}u = \xi K_{u\theta}\theta + f$$
  
 $C_{\theta\theta}\dot{\theta} + \eta K_{\theta\theta}\theta = -C_{\theta u}\dot{u}$ 

- Micron-scale poly-Si devices:  $\xi$  and  $\eta$  are  $\sim$  10<sup>-4</sup>.
- Linearize about  $\xi = 0$

## Perturbative Mode Calculation

#### Discretized mode equation:

$$(-\omega^2 M_{uu} + K_{uu})u = \xi K_{u\theta}\theta$$
$$(i\omega C_{\theta\theta} + \eta K_{\theta\theta})\theta = -i\omega C_{\theta u}u$$

33 / 65

## Perturbative Mode Calculation

First approximation about  $\xi = 0$ :

$$(-\omega_0^2 M_{uu} + K_{uu})u_0 = 0$$
  
$$(i\omega_0 C_{\theta\theta} + \eta K_{\theta\theta})\theta_0 = -i\omega_0 C_{\theta u}u_0$$

First-order correction in  $\xi$ :

$$-\delta(\omega^2)M_{uu}u_0 + (-\omega_0^2M_{uu} + K_{uu})\delta u = \xi K_{u\theta}\theta_0$$

Multiply by  $u_0^T$ :

$$\delta(\omega^2) = -\xi \left( \frac{u_0^T K_{u\theta} \theta_0}{u_0^T M_{uu} u_0} \right)$$

## The Power of Perturbation

- Full method: nonsymmetric eigensolve of size
- Perturbation method:
  - Purely mechanical symmetric eigensolve
  - 2 Linear solve for corresponding thermal field
  - A couple dot products for frequency correction

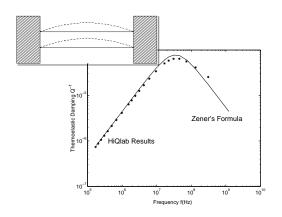
35 / 65

## Zener's Model

- Clarence Zener investigated TED in late 30s-early 40s.
- Model for beams common in MEMS literature.
- "Method of orthogonal thermodynamic potentials" == perturbation method + a variational method.

36 / 65

# Comparison to Zener's Model



- Comparison of fully coupled simulation to Zener approximation over a range of frequencies
- Real and imaginary parts after first-order correction agree to about three digits with Arnoldi

## Onward!

The purpose of computing is insight, not numbers.

Richard Hamming

#### What about:

- Modeling more geometrically complex devices?
- Modeling general dependence on geometry?
- Modeling general dependence on operating point?
- Computing nonlinear dynamics?
- Digesting all this to help designers?

## Conclusions

- RF MEMS are still a great source of problems
  - Still many unresolved physical modeling problems
  - Need better parameterized and nonlinear model reduction methods
  - System scale simulations mean parallel computing challenges

http://www.cims.nyu.edu/~dbindel